Role of Acid Mixtures Etching on the Surface Chemistry and Sodium Ion Storage in Ti$_3$C$_2$Tx MXene
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Two-dimensional transition metal carbides and/or nitrides (MXenes) have shown promise in developing electrochemical storage of metal ions within conductive galleries due to redox reactions with transition metal atoms. Here, effect of surface chemistry on electrochemical storage of sodium ions in MXene interlayer is investigated by etching Ti$_3$AlC$_2$ MAX using different etchants – HF, HF/HCl, and HF/$_2$SO$_4$.

MXenes, a large family of layered materials comprised of transition metal carbides, nitrides, and carbonitrides, have become attractive candidates for a plethora of applications due to their compositional versatility and rich surface chemistry, leading to diverse physicochemical properties. MXenes are synthesized through top-down wet chemical etching of MAX phases (M$_{n+1}$AX$_n$). M is an early transition metal such as Ti, V, Nb, Cr, Mo and A is Al, Ga, In, and X is C and/or N, where interleaved 'A' atomic layers are selectively extracted by fluoride containing etchants and replaced with surface functional groups (–F, =O, –OH, –Cl). MXenes are hydrophilic yet the majority exhibit metallic conductivity and are generally represented by the formula M$_{n+1}$X$_n$$^x$T$_x$, where 'MX' lamellas are the same as in the MAX phase, and T$_x$ refers to the surface functional groups. Colloidal suspensions of MXenes can be obtained through delamination of multilayered MXene lamellas by organic solvents, and inorganic and organic cations. Therefore, etching conditions, type of intercalant and the process of delamination have a strong impact on the optical, electronic, and physico-chemical properties of MXenes. Titanium carbide MXene (Ti$_3$C$_2$T$_x$) is the most widely studied member in the MXene family and was the first MXene discovered. It has well-developed etching and delamination protocols, and it exhibits good chemical stability in dispersion and solid forms. Furthermore, Ti$_3$C$_2$T$_x$ exhibits unique properties such as record values of electrical conductivity exceeding 10,000 S/cm (free-standing films delaminated by lithium ions), a key parameter for a wide range of applications including electromagnetic interference shielding, electronics, wireless communication, and high-rate energy storage.

There have been a few studies on the effect of etching conditions on the surface chemistry of MXenes. For example, Hope et al. investigated the surface of Ti$_3$C$_2$T$_x$ produced by HF and LiF/HCl methods using nuclear magnetic resonance (NMR) technique to confirm the coordination of -F and -OH as surface termination groups. Moreover, Sang et al. reported that the milder LiF/HCl etchant produces higher quality MXenes with lower concentration of point defects compared to 50 wt.% HF. Therefore, etchants with low concentration of HF (<10 wt%) are being used for Ti$_3$C$_2$T$_x$ synthesis due to recent demand for high quality MXenes for electronic and optoelectronic applications. However, there has been no systematic study on the nature of MXenes produced using low concentration of HF or using different anions in solution during the etching process. Our group previously reported that Ti$_3$C$_2$T$_x$ produced using HF/$_2$SO$_4$ showed better electrochemical energy storage of Na-ions compared to Ti$_3$C$_2$T$_x$ produced using HF and HF/HCl; however, no surface chemistry characterization was reported. Similarly, the aforementioned etching recipes for synthesis and processing of Ti$_3$C$_2$T$_x$ were previously demonstrated separately, but not compared directly using the same HF concentration. Therefore, it is important to understand the surface chemistry state and analyze the remaining etching products in order to better control the factors that govern the chemical and electrochemical properties of MXenes.

In this study, we used HF and different acid mixtures, HF/HCl and HF/$_2$SO$_4$ – where the concentration of HF was 5 wt.% in all cases – to etch Ti$_3$AlC$_2$ MAX phase (Fig. 1a). In order to exclude the effect of Li-ions pre-intercalation, produced during in-situ etching methods employing LiF/HCl into the...
multilayered MXene structure, this method was not investigated. The materials were also investigated at the multilayer stage in order to avoid any variations from the delamination process.\(^4\)

X-ray diffraction (Fig. 1b) provides insight into the structural transformation of parent Ti\(_3\)AlC\(_2\) MAX to Ti\(_3\)C\(_2\)T\(_x\) MXenes. The (002) index is indicative of stacking order and interlayer spacing between Ti\(_3\)C\(_2\)T\(_x\) layers. The (002) peak appears broader and the intensity of the (002) peak shifts from \(2\theta = 9.5^\circ\) in Ti\(_3\)AlC\(_2\) (Fig. S1a, Electronic Supplementary Information) to lower \(2\theta = 9.1^\circ\) in Ti\(_3\)C\(_2\)T\(_x\) (HF) (Fig. 1b), indicating that the interlayer spacing expands from 9.3 to 9.7 Å. Similarly, Ti\(_3\)C\(_2\)T\(_x\) (HF/HCl) and Ti\(_3\)C\(_2\)T\(_x\) (HF/H\(_2\)SO\(_4\)) samples have (002) peaks shifted to lower \(2\theta\) values of 8.5° and 9.2°, corresponding to interlayer spacing values of 10.2 and 9.4 Å, respectively. The larger interlayer spacing values for Ti\(_3\)C\(_2\)T\(_x\) samples with respect to Ti\(_3\)AlC\(_2\) suggest that a minimal concentration of HF (5 wt.%) with/without the presence of other inorganic acids can accomplish the etching process with subsequent attachment of functional groups, Ti\(_4\) (-OH, =O, -F, -Cl), as shown previously.\(^9\) The subtle differences in the interlayer spacing of Ti\(_3\)C\(_2\)T\(_x\) samples can be attributed to differences in the surface terminations and etching products, which can cause local variations in the interlayer spacing of MXene sheets.

![Schematic illustrating the synthesis of Ti\(_3\)C\(_2\)T\(_x\) MXene from the parent MAX phase by employing either HF, HF/HCl or HF/H\(_2\)SO\(_4\) etchants at a temperature of 40 ºC for 15 h (a). The corresponding XRD patterns (b) and SEM images of multilayered Ti\(_3\)C\(_2\)T\(_x\) (HF) (c), Ti\(_3\)C\(_2\)T\(_x\) (HF/HCl) (d) and Ti\(_3\)C\(_2\)T\(_x\) (HF/H\(_2\)SO\(_4\)) (e). HF concentration was 5 wt.% in all three cases.](image)

Also, since neither sonication nor delamination was done in this case, the morphology of MXene stacks observed was more compact. Overall, this indicates that morphology of the MXene layers is dependent on the concentration and type of etchant used for etching MAX.

![13C NMR (a), and 1H NMR (b) spectra of Ti\(_3\)C\(_2\)T\(_x\) (HF), Ti\(_3\)C\(_2\)T\(_x\) (HF/HCl) and Ti\(_3\)C\(_2\)T\(_x\) (HF/H\(_2\)SO\(_4\)) samples.](image)

Solid-state NMR was used to probe the coordination of MXene core, surface terminations, and intercalants.\(^{13}\) NMR spectra (Fig. 2a) show that precursor Ti\(_3\)AlC\(_2\) was converted to Ti\(_3\)C\(_2\)T\(_x\) as indicated by the shift in the peak from ~565 ppm to ~400 ppm, which is in agreement with previously reported chemical-shifts for Ti\(_3\)C\(_2\)T\(_x\).\(^6,10\) The disappearance of the Ti\(_3\)AlC\(_2\) peak also points to complete or partial etching of all Ti\(_3\)AlC\(_2\), further confirming with the XRD (Fig. 2a) results, that 5 wt% HF with/without the presence of anions is enough to etch the Al layers. However, minute differences exist in the 13C NMR spectra for the different samples, where the resonant peak for Ti\(_3\)C\(_2\)T\(_x\) (HF) and (HF/HCl) is found at ~398 ppm, while for Ti\(_3\)C\(_2\)T\(_x\) (HF/H\(_2\)SO\(_4\)) it is found at ~389 ppm. These differences could stem from more electronegative species on the surface, such as hydrofluorocarbons in Ti\(_3\)C\(_2\)T\(_x\) (HF), and higher amount of -O and -Cl terminations in Ti\(_3\)C\(_2\)T\(_x\) (HF/HCl), which lead to a more diffuse overlap of Ti 3d with C 2p orbitals. This difference in the electron densities around the Ti and C leads to a more de-shielded 13C nucleus and thus a larger chemical shift. Moreover, the resonance peak for the Ti\(_3\)C\(_2\)T\(_x\) (HF/HCl) sample appears broader than that of the other samples, which suggests a longer T\(_2\) relaxation time, and thus a higher electron density on Ti atoms. However, this is contrary to the four-point probe measurements where Ti\(_3\)C\(_2\)T\(_x\) (HF/H\(_2\)SO\(_4\)) was found to exhibit the highest conductivity (Fig. S1b, ESI). Thus, further studies are needed to understand the differences, which may stem from other factors such as presence of Ti vacancies or lack thereof.\(^7\)

\(^{13}\)H NMR spectra (Fig. 2b) showed a broad peak around 15-20 ppm assigned to Ti-OH surface terminations, an intermediate peak ~7 ppm assigned to intercalated water, and a sharp peak ~0 ppm assigned to intercalated contaminants.\(^6,10\) The following discussion highlights the advantages of using
\(^1\)H NMR spectra to distinguish between H\(_2\)O and OH signals compared to other characterization techniques.

Interestingly, the Ti-OH peak is broader for Ti\(_3\)CT\(_x\) (HF) compared to Ti\(_3\)CT\(_x\) (HF/HCl) and Ti\(_3\)CT\(_x\) (HF/H\(_2\)SO\(_4\)). The differences are attributed to variations in the local environment, i.e., the type and amount of neighbouring surface terminations. For example, it is possible that −Cl surface terminations on the Ti\(_3\)CT\(_x\) (HF/HCl) sample could be responsible for a chemical shift of -5 ppm for Ti-OH signals (XPS data, Fig. S2, ESI). On the other hand, the −OH surface terminations might be due to two different sites or interactions on the surface as indicated by the two dashed lines in Fig. 2b. The Ti\(_3\)CT\(_x\) (HF) sample exhibits both sites based on the peaks at 15 ppm and 21 ppm, while the Ti\(_3\)CT\(_x\) (HF/HCl) sample exhibits only the first site based on the peak at 14 ppm. In the case of the Ti\(_3\)CT\(_x\) (HF/H\(_2\)SO\(_4\)) sample, the peak at 20 ppm suggests the material only has the second site. This follows Persson et al., where it was proposed that 0 1s XPS spectra for Ti\(_3\)CT\(_x\) can be deconvoluted into two contributions from oxygen surface terminations in the A site, with and without interactions from nearby fluoride surface terminations.\(^1\)

Furthermore, the relative ratio of H\(_2\)O signal to Ti-OH signal can be used as a measure of the amount of structural water in the samples, which was found to be higher for Ti\(_3\)CT\(_x\) (HF/HCl) compared to other etching methods (Fig. 2b). Moreover, higher amount of water in Ti\(_3\)CT\(_x\) (HF/HCl) was also confirmed by a broader (002) peak in XRD (Fig. 1b) and thermogravimetric analysis coupled with mass spectrometry data (Fig. S3-S4, ESI).

Fig. 3 Na-ion half-cells using Ti\(_3\)CT\(_x\) MXene pellet electrodes. Cyclic voltammograms showing first three cycles at a scan rate of 0.1 mV/s using working electrodes of Ti\(_3\)CT\(_x\) (HF) (a), Ti\(_3\)CT\(_x\) (HF/HCl) (b) and Ti\(_3\)CT\(_x\) (HF/H\(_2\)SO\(_4\)) (c). CVs of Ti\(_3\)CT\(_x\) (HF/H\(_2\)SO\(_4\)) at different scan rates (d).

To investigate the intrinsic electrochemical Na-ion intercalation and storage in Ti\(_3\)CT\(_x\) Na-ion half-cells were assembled. Multilayered Ti\(_3\)CT\(_x\) powders were cold pressed into disc electrodes with thickness ~ 270 µm and density ~ 2.8 g/cm\(^3\) (for 100 mg powder). Density of Ti\(_3\)CT\(_x\) pellets was about three times higher compared to conventional slurry casting method (0.8-1 g/cm\(^3\)). Thus, obtained Ti\(_3\)CT\(_x\) discs were binder and conductive additive-free and were directly used as working electrodes in assembling Na-ion half cells with Na-foil as counter and reference electrodes in non-aqueous Na\(^+\) electrolyte. As shown in Fig. 3, CV scans for the first three cycles are displayed at a scan rate of 0.1 mV/s in the potential range of 0.01 - 3 V (vs. Na\(^+\)/Na). The first cycle Coulombic Efficiency values were found to be 64%, 53% and 60% for the Ti\(_3\)CT\(_x\) HF, HF/HCl, and HF/H\(_2\)SO\(_4\) etched electrodes, respectively. First cycle irreversibility differences could be attributed to the different surface terminations and amounts of structural water in those samples.\(^1\) For example, Kurahashi et al. reported that fluoride and oxygen surface terminations are favorable for sodium ion adsorption in opposition to hydroxyl surface terminations.\(^1\)\(^3\) The electrochemical results corroborate very well with the XPS, NMR and mass spectrometry data.

Interestingly, Ti\(_3\)CT\(_x\) MXene electrodes showed redox peaks above 2 V (vs. Na\(^+\)/Na), which can be attributed to the redox reaction of the Ti\(^{3+}/Ti^{2+}\) couple.\(^1\)\(^4\) Traditionally, titanium-based electrodes benefit from the redox reaction of Ti\(^{3+}/Ti^{2+}\) to insert Na-ions.\(^1\)\(^4\) Therefore, the intrinsic redox nature of Ti\(_3\)CT\(_x\) might be preserved by employing mild concentration of fluoride solutions during the etching process. For instance, as can be seen from Fig. 3a, Ti\(_3\)CT\(_x\) (HF) showed two pairs of redox peaks (oxidation/reduction at 2.37 V/2.02 V and 2.55 V/2.21 V vs. (Na\(^+\)/Na)) while Ti\(_3\)CT\(_x\) (HF/HCl) and Ti\(_3\)CT\(_x\) (HF/H\(_2\)SO\(_4\)) electrodes showed a single pair of redox peaks positioned at 2.52 V/2.25 V and 2.41 V/2.12 V, respectively (Figs. 3b, 3c). These experiments suggest that the titanium surface state and oxidation differ in each case as suggested by the positions of redox peaks. However, the prominent appearance of redox peaks in all three cases is an indication for the intrinsic redox behavior of Ti\(_3\)CT\(_x\). Similarly, Dall’agnese et al. also observed prominent redox peaks for V\(_2\)CT\(_x\) electrodes in non-aqueous Na\(^+\) electrolyte.\(^1\)\(^5\) Therefore, metal surfaces such as Ti and V can show redox nature in non-aqueous electrolytes as well.\(^1\)\(^6\) This could be due to ion insertion induced redox reaction of the metal atoms of MXene, by maintaining charge neutrality.\(^1\)\(^7\)

Compared to HF and HF/HCl, HF/H\(_2\)SO\(_4\) etched sample showed close to rectangular CV shape below 2 V and more pronounced redox peaks above 2 V (vs. Na\(^+\)/Na). This might be due to the clean surface of MXene electrodes, as H\(_2\)SO\(_4\) can dissolve and remove the etching by-products as indicated by \(^1\)H NMR results (Fig. S5, ESI), and also superior conductivity over other samples – 96, 110, and 714 S/cm for HF, HF/HCl, and HF/H\(_2\)SO\(_4\) etched samples pressed into disc electrodes, respectively. Further, Ti\(_3\)CT\(_x\) (HF/H\(_2\)SO\(_4\)) pellets were swept at different scan rates and showed prominent redox peaks (Fig. 3d). Anodic and cathodic peak current responses vary linearly with the scan rate (0.1-0.5 mV/s), suggesting that surface controlled redox reactions occur.

After the initial Na\(^+\) intercalation, Ti\(_3\)CT\(_x\) electrodes exhibit pseudocapacitive behavior and stable rectangular CV below 2 V (Vs. Na\(^+\)/Na), corresponding to typical capacitor behavior, at such high mass-loading of 75 mg/cm\(^2\) (commercial scale mass-loading is ~10 mg/cm\(^2\)), and gravimetric capacity of 44 mAh/g at 0.1 mV/s (corresponding to volumetric capacity of 124
mAH/cm²). Typical areal capacities vary from 3.3 to 2.1 mAH/cm² in the scan rate of 0.1 to 0.5 mV/s. Kim et al. also reported stable lithiation capacities up to 5 mAH/cm² for Ti₃C₂Tx electrodes at a similarly high mass-loading of 50 mg/cm². 18 As this study mainly focuses on determining the influence of etching conditions on the surface chemistry and the intrinsic electrochemical properties, the electrochemical performance and its optimization should be the focus of further studies.

In summary, systematic investigation of etching Ti₃AlC₂ MAX using three different etchants – HF, HF/HCl, and HF/H₂SO₄ – led to Ti₃C₂Tx MXenes with diverse surface terminations (=O, -OH, -F, and -Cl) and different amounts of structural water. HF/HCl etching produced -Cl terminations, which might be the cause for the observed larger interlayer spacing and larger amount of structural water compared to HF and HF/H₂SO₄ etched samples. Etching with HF/H₂SO₄ led to only a trace sulfur signal and the highest electrical conductivity and thermal stability values compared to the other etching methods. Furthermore, 1H NMR revealed variations in the Ti-OH peaks for the different samples, which could be attributed to multiple adsorption sites for -OH surface terminations; with and without interaction of nearby fluoride. Investigation of electrochemical sodium ion intercalation revealed that Ti₃C₂Tx (HF/H₂SO₄) sample had lower first cycle irreversibility and better overall electrochemical performance, which may be attributed to a cleaner surface due to better removal of etching by-products and structural water. Since the three etching methods were shown to influence the surface chemistry and physicochemical properties of MXenes, this work highlights the need to further investigate their impact on physicochemical properties, as well as the performance of MXenes in various applications aside from Na-ion storage, such as electromagnetic interference shielding or antennas, which rely heavily on the electrical conductivity of the material.

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Conflicts of interest

There are no conflicts to declare.

References

The following is the caption to accompany the table of contents entry graphic:

*Optimizing the etchants for MXene synthesis to remove etching byproducts, obtain pristine surface chemistry, and improve energy storage performance.*